

1612.63479



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#Q5/Amd+E
4/17/03
C.P.

In Re U.S. Patent Application)
Applicant: Hongyong Zhang)
Serial No. 09/468,489)
Filed: December 20, 1999)
For: THIN FILM TRANSISTOR)
HAVING LIGHTLY AND)
HEAVILY DOPED SOURCE/)
DRAIN REGIONS AND ITS)
MANUFACTURE)
Art Unit: 2814)
Examiner: Quach, T.)

I hereby certify that this paper is being deposited with the
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April 4, 2003
Date

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AMENDMENT E

BOX RCE
Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In response to the Office Action mailed December 4, 2002, please amend the
above-identified Application as follows: